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## APPLICANTS

Frederic Mazen, Grenoble, FRANCE;

Thierry Baron, Grenoble, FRANCE;

Jean-Michel Hartmann, Meylan, FRANCE; Marie-Noelle Semeria, Grenoble, FRANCE;

\*\* CONTINUING DATA \*\*\*\*\* *NM*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *YEP*

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance	FRANCE	DRAWING 1	20	1
Verified and Acknowledged	Examiner's Signature <i>MJ</i> Initials				

## ADDRESS

Robert E. Krebs  
 Thelen Reid & Priest LLP  
 P.O. Box 640640  
 San Jose , CA  
 95164-0640

## TITLE

Method for forming, by CVD, nanostructures of semi-conductor material of homogeneous and controlled size on dielectric material

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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